Applicants thank the Examiner for the courtesy of a brief interview on April 22, 2005 to discuss the current position of the pending application. Enclosed with this response is a Request for Continued Examination to smooth the further processing of the present application. Claims 1-15 are active. Claims 16-20 have been withdrawn. Claims 9-15 have been allowed and claim 4 has been held allowable.

In the previous Office action, the Examiner indicated that claim 1 did not have explicit language requiring the conductive path in the material layer be produced *before* attaching the handle wafer. And for that reason, Applicants' previous arguments distinguishing the Wachtmann reference were rejected. The present amendment changes claim 1 to explicitly add the foregoing requirement. Thus, Applicants believe that the Examiner's concerns have been satisfied, and that claims 1-8, line claims 9-15 are now allowable.

Conclusion

Applicants believe that no extension of time is required; however, this conditional petition is made to provide for the possibility that the applicant has inadvertently overlooked the need for an extension of time. If any additional fees are required for the timely consideration of this application, please charge deposit account number 19-4972.

In view of the foregoing remarks, Applicants believe this application is now in condition for allowance. A notice to this effect is respectfully requested. If the Examiner believes, after this response, that the application is not in condition for allowance, the Examiner is invited to call applicants' attorney at the telephone number listed below.

Attorney Docket: **2550/174** Application 10/601,980 Filed 6/23/03

Respectfully submitted,

Jay Sandvos

Registration No. 43,900 Attorney for Applicant

BROMBERG & SUNSTEIN LLP
125 Summer Street

Boston, MA 02110-1618 Tel: (617) 443-9292

Fax: (617) 443-0004 02550/00174 381315.1



BROMBERG * SUNSTEIN ...

125 SUMMER STREET BOSTON MA 02110-1618

Mail Stop RCE

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

11	C/	174	-1

Please Date Stamp and Return

The Commissioner for Patents has received from Bromberg & Sunstein LLP the following re:

nventor: Fitle:	Wachtmann et al. Apparatus and Method of Forming a Device Layer	Docke Art Un Exami	iit:	2550/174 2818 Tran, Long
Serial/Patent No.: Filing/Issue Date:	10/601,980 June 23, 2003	Date: Expres	s Mail No.:	May 5, 2005
Documents: New Application T Provisional Applic Description- Claims- page Abstract Application Data S Request and Certif sheets of dra formal Declaration & Pow executed	ation Cover Sheet pages es Sheet ication under 35 USC 122(b)(2)(B)(i) awings informal	 	Issue Fee Trans Payment of Assignment/Re Check in the ar Completion of Transmittal of	reliminary)
				